

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10063887	FILING DATE 05/21/2002	CLASS 257 033	SUBCLASS 620	GAU 2822 2659	EXAMINER PRENTY
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\*APPLICANTS: Fu Chien-Chih;

\*\*CONTINUING DATA VERIFIED:

None

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\*\* FOREIGN APPLICATIONS VERIFIED:

TAIWAN 091101405 01/28/2002

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no MP	ATTORNEY DOCKET NO AMIP0015USA
TITLE : Scribe lines for increasing wafer utilizable area			
U.S.DEP.T. OF COMM./PAT & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED			
			Total Claims	Print Claim for O.G.	DRAWING	
ISSUE FEE				Sheet(s) Drwg.	Figs. Drwg.	Print Fig.
Amount Due	Date Paid					
		Primary Examiner				
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner		
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